

**AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROSECUTION - GROUP ART UNIT 2823**

03500.017456

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KAZUHIRO KAGAMI ET AL.

Application No.: 10/627,645

Filed: July 28, 2003

For: BASE PATTERN FORMING
MATERIAL FOR ELECTRODE
AND WIRING MATERIAL
ABSORPTION, ELECTRODE
AND WIRING FORMING
METHOD, AND METHOD OF
MANUFACTURING IMAGE
FORMING APPARATUS

Examiner: H. M. Lee

Group Art Unit: 2823

April 4, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Mail Stop AF

AMENDMENT AFTER FINAL REJECTION

Sir:

A. Introductory Comments

In response to the Office Action dated February 3, 2005, please amend the application as follows and consider the following remarks.

I hereby certify that this correspondence is being facsimile-transmitted to the United States Patent and Trademark Office, Fax No. (703) 872-9306, on

April 4, 2005
(Date of Transmission)

Jason M. Okun
(Name of Attorney for Applicants)

Signature

April 4, 2005
Date of Signature